







<u>Compact opto-semiconductors with excellent photon counting capability</u>







O New type of Si Photon Counting Device

The MPPC (Multi-Pixel Photon Counter) is a new type of photon counting device made up of multiple APD (avalanche photodiode) pixels operated in Geiger mode. The MPPC is essentially an opto-semiconductor device with excellent photon counting capability and which also possesses great advantages such as low voltage operation and insensitivity to magnetic fields.

Features

- \cdot Excellent photon counting capability (Excellent detection efficiency versus number of incident photons)
- · Room temperature operation
- · Low bias (below 100 V) operation
- High gain: 10⁵ to 10⁶
- Insensitive to magnetic fields
- · Excellent time resolution
- Small size
- Simple readout circuit operation
- MPPC module available (option)





S10362-11-025U/-050U/-100U

S10362-11-025C/-050C/-100C



The MPPC is a kind of so-called Si-PM (Silicon Photomultiplier) devices. It is a photon counting device consisting of multiple APD pixels operating in Geiger mode. Each APD pixel of the MPPC outputs a pulse signal when it detects one photon. The signal output from the MPPC is the total sum of the outputs from all APD pixels. The MPPC offers the high-performance needed in photon counting and is used in diverse applications for detecting extremely weak light at the photon counting level.

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Photon counting by MPPC

The light we usually see consists of a stream of light particles (photons) that produce a certain brightness. When this brightness falls to a very low level, the incoming photons are now separate from each other. Photon counting is a technique to measure low light levels by counting the number of photons. Photomultiplier tubes and APDs (avalanche photodiodes) are the most popular photon counting devices.



APDs are high-speed, high-sensitivity photodiodes that internally amplify photocurrent when a reverse bias is applied.

HAMAMATSU APD has high sensitivity to short wavelength light emitted from commonly used scintillators. Its structure allows a high fill factor to ensure high photon detection efficiency. When the reverse bias applied to an APD is set higher than the breakdown voltage, the internal electric field becomes so high that a huge gain (10⁵ to 10⁶) can be obtained. Operating an APD under this condition is called "Geiger mode" operation. During Geiger mode, a very large pulse is generated when a carrier is injected into the avalanche layer by means of incident photon. Detecting this pulse makes it possible to detect single photons.

The MPPC is made up of multiple APD pixels operated in Geiger mode. The sum of the output from each pixel forms the MPPC output, which allows the photons to be counted.



Excellent photon counting capability

The MPPC delivers superb photon counting performance. Connecting the MPPC to a linear amplifier will show sharp waveforms on an oscilloscope according to the number of detected photons.

Pulse waveform when using a linear amplifier (120 times) (S10362-11-050U, M=7.5 × 10⁵)



NUMBER OF PHOTONS

pixels making up the MPPC.

The fact that the individual peaks are clearly separate from each other in the pulse height spectrum below, proves there is little variation between the gains of APD

TIME





Deveryorten	Symbol	S10362-11 series			
Parameter		-025U, -025C	-050U, -050C	-100U, -100C	Unit
Chip size	-	1.5 × 1.5			mm
Effective active area	-	1 × 1			mm
Number of pixels -		1600	400	100	-
Pixel size	-	25 imes 25	50 imes 50	100 × 100	μm
Fill factor *1	-	30.8	61.5	78.5	%
Spectral response range	λ	270 to 900			
Peak sensitivity wavelength	λρ	400			nm
Quantum efficiency ($\lambda = \lambda p$)	QE	70 Min.			%
Photon detection efficiency $(\lambda = \lambda p)$	PDE	25	50	65	%
Recommended operating voltage range	-	70 ± 10 *3			
Dark count	-	100	270	400	kcps
Terminal capacitance	Ct	35			pF
Time resolution (FWHM)	-	250	220	250	ps
Temperature coefficient of reverse bias	-	50			mV/°C
Gain	М	2.75 × 10⁵	7.5 × 10⁵	$2.4 imes 10^{6}$	-

Specifications (Ta=25 °C, Typ. unless otherwise noted)

*1: Ratio of the active area of a pixel to the entire area of the pixel.

*2: Photon detection efficiency includes crosstalk and afterpulses.

*3: For the recommended operating voltage of each product, refer to the data attached to each product.

Note: The last letter of each type number indicates package materials (U: metal, C: ceramic).

Dimensional outlines (unit: mm)

S10362-11-025U/-050U/-100U







KAPDA0121EA

S10362-11-025C/-050C/-100C







KAPDA0122EA

Basic connection diagram for MPPC



Under development

Related product MPPC module

The MPPC module is a photon counting module capable of lowlight-level detection. This module consists of an MPPC device, current-to-voltage converter circuit, high-speed comparator circuit, high-voltage power supply circuit, temperature-compensation circuit, counter circuit, and microcomputer. The module also has a USB port for connecting to a PC. The threshold level (detection level for one photon) can be changed from a PC. The MPPC module is designed to extract maximum MPPC performance and so yields excellent photon counting characteristics. Potential applications include drug discovery, high energy physics experiments, fluorescence measurement, environmental chemical analysis as well as many other areas in a wide range of fields.



Specifications (Ta=25 °C)

Parameter	Symbol	Condition	C10507-11-025U	C10507-11-050U	Unit
Internal MPPC	-		S10362-11-025U	S10362-11-050U	-
Effective active area	-		1 × 1		mm
Number of pixels	-		1600	400	-
Peak sensitivity wavelength λp		400		nm	
Output voltage	-		100		mV/p.e.
Dark count	-	0.5 p.e.	100	270	kcps
Photon detection efficiency *4 ($\lambda = \lambda p$)	PDE		25	50	%
Temperature coefficient of gain	-	25 ± 10 °C	±2.5		%
Comparator threshold level -		Adjustable		-	
Interface	-		USB		-
Board dimension	-		80 × 55		mm

*4: Photon detection efficiency includes crosstalk and afterpulses.

Block diagram



We are also developing MPPC modules that use an optical fiber attached to the detector section or a scintillator coupled to the detector.

C10507-11 series

Applications that utilize low-light-level detection

The MPPC is used in diverse applications for detecting extremely weak light at the photon counting level.

The MPPC offers the high-performance needed in photon counting. It offers the advantages of high gain under operation at a low bias voltage, high photon detection efficiency, high-speed response, high count rate, excellent time resolution, and wide spectral response range. Because the MPPC is a solid-state device, there are additional benefits, such as high resistance to shock and impact, no burn-in phenomenon from input light saturation, and photon counting at room temperature since the MPPC needs no cooling. All these features make the MPPC a substitute for existing detectors that have been used in photon counting and opens up all kinds of future possibilities.

The fact that the MPPC operation is simple and provides high-performance detection makes it promising for photon counting applications where extreme photodetector sensitivity is needed. The MPPC is ideal for a wide range of fields including fluorescence analysis, fluorescence lifetime measurement, biological flow cytometry, confocal microscopes, biochemical sensors, bioluminescence analysis, and single molecular detection.

Another great feature of the MPPC is that it is not susceptible to magnetic fields. This means that, for example, when the MPPC is used as a detector for a PET (Positron Emission Tomography) scanner, the PET can be integrated into an MRI (Magnetic Resonance Imaging) system to create a new type of equipment. Furthermore, the MPPC can be put into use in high energy physics experiments because of features, such as room temperature operation, low bias voltage, and small size suitable for high density assembly.



Examples of MPPC applications

KAPDC0038EA

In PET scanners and high-energy calorimeter applications, the number of incident photons is usually large so the MPPC with large number of pixels and small pixel pitch is used.

High photon detection efficiency is essential in applications, such as fluorescence measurement and Cherenkov light detection where the number of incident photons is extremely small. In these fields, the MPPC with small number of pixels, large pitch and high fill factor is used.



Geiger mode is a method for operating an APD at a reverse bias higher than the breakdown voltage. A high electric field is produced in the APD during Geiger mode so that a discharge occurs even from a weak light input. This phenomenon is known as "Geiger discharge". The electron gain at this point is as high as 10⁵ or 10⁶ and the magnitude of the output current is constant regardless of the number of input photons.

When a quenching resistor is connected to the Geiger mode APD (see Figure 1), the APD operates as shown in Figure 2.

[Table 1] Operation modes of APD

Operation mode	Reverse bias	Gain	
Normal mode	Below breakdown voltage	Dozens to several hundred	
Geiger mode	Above breakdown voltage	10 ⁵ to 10 ⁶	

[Figure 1] Geiger mode APD and quenching resistor —



[Figure 2] Geiger mode APD operation ——



 Discharge (output from pixel)
When photons strike an APD pixel during Geiger mode, a constant signal Q=C × (VR - VBR) is produced from the pixel, independent of the number of photons. · Quenching

When a current flows through the quenching resistor, the reverse voltage drops to VBR.

· Recharge

The reserve bias returns to VR by recharge, so Geiger mode operation can begin again.



MPPC is made up of multiple APD pixels connected in parallel and operated in Geiger mode (Figure 3). When photons enter each APD pixel during Geiger mode, the pulse output from the pixel is constant regardless of the number of photons. This means that each APD pixel only provides information on whether or not it received one or more photons. A quenching resistor is connected to each APD pixel to allow output current to flow through it. Since all APD pixels are connected to one readout channel, the output pulses from the APD pixels overlap each other, creating a large pulse. By measuring the height or electrical charge of this pulse, the number of photons detected by the MPPC can be estimated.

Qout = $C \times (V_R - V_{BR}) \times Nfired \cdots (1)$

C: Capacitance of one APD pixel Nfired: Number of APD pixels that detected photons





Gain can be estimated from the output charge of the MPPC that detected photons. The gain varies with the reverse bias voltage applied to the MPPC. Figure 4 below shows a typical connection for gain measurement.

[Figure 4] Connection diagram for gain measurement setup (using charge amplifier)



Pulsed light is sufficiently reduced in intensity by the optical attenuator and is irradiated onto the MPPC. The MPPC output is then processed by the PC to obtain a frequency distribution for that output charge. A distribution example is shown in Figure 5.

[Figure 5] Frequency distribution example of output charge



In Figure 5, the horizontal axis is the ADC channels that represent the amount of digitized output charge from the MPPC. The ADC conversion rate (electric charge per channel) in Figure 5 is 0.382 fC/ch. The output charge is increasing to the right on the horizontal axis. The vertical axis is the frequency (number of events) at each channel (output charge). As can be seen from Figure 5, the distribution curve is separate, indicating output results characteristic of the MPPC. The peak of each curve starting from the left shows: the pedestal, 1 p.e. (one photon equivalent), 2 p.e., 3 p.e., etc. This example indicates that pulsed light of mostly

one or two photons strikes the MPPC.

The distance between adjacent peaks exactly equals the output charge of one detected photon. The gain (multiplication) is therefore expressed by the following equation.

Gain = $\frac{\text{Number of channels between 2 peaks × ADC conversion rate}}{1 \text{ electron charge}} \cdots$ (2)

The number of channels between two adjacent peaks is 130 ch as seen from Figure 5, the ADC conversion rate is 0.382 fC/ch, and the electric charge of an electron is 1.6×10^{-19} C, so the gain can be given as follows:

$$\frac{130 \times 0.382 \times 10^{-15}}{1.6 \times 10^{-19}} = 3.10 \times 10^{5}$$

To enhance accuracy, the gain is calculated by averaging the peak values between multiple channels.



n Gain linearity

Gain of MPPC has excellent linearity vs. reverse bias.

[Figure 6] Gain vs. reverse bias (a) S10362-11-025U/C



(b) S10362-11-050U/C, S10362-11-100U/C



Temperature characteristic of gain

The MPPC gain is temperature dependent. As the temperature rises, the lattice vibrations in the crystal become stronger. This increases the probability that carriers may strike the crystal before the accelerated carrier energy has become large enough, and make it difficult for ionization to occur. Moreover, as the temperature rises, the gain at a fixed reverse bias drops. In order to obtain a stable output, it is essential to change the reverse bias according to the temperature or keep the device at a constant temperature.

[Figure 7] Reverse bias vs. ambient temperature —— (a) S10362-11-025U/C



(b) S10362-11-050U/C, S10362-11-100U/C



3-5 Dark count measurement

The MPPC is a solid-state device so it generates noise due to thermal excitation. The noise component is amplified in Geiger mode operation and the original photon detection signal cannot be discriminated from the noise. This noise occurs randomly so its frequency (dark count) is a crucial parameter in determining MPPC device characteristics.

Setting the photon detection threshold (when counting the number of times that a certain number of photons are simultaneously detected) Connecting a linear amplifier to the MPPC and measuring the height of the output pulses allow counting the number of times that a certain number of photons are simultaneously detected. This section explains the method for setting a threshold according to the number of photons and measuring the number of output pulses exceeding the threshold height with a frequency counter *.

* An instrument for measuring the number of pulses exceeding a threshold level.

[Figure 8] Dark count measurement setup-



(1) Counting the number of times that one or more photons are detected

Set the threshold at one-half (0.5 p.e.) height of the "1 p.e.". Counting the number of pulses that exceeds this threshold gives the number of times that one or more photons are detected.

[Figure 9] MPPC output waveform seen on oscilloscope



(2) Detecting two or more (or N or more) photons simultaneously

To count the number of times that two or more photons are detected simultaneously, set the threshold at the midpoint (1.5 p.e.) between "1 p.e." and "2 p.e.". To count the number of times that N or more photons are simultaneously detected, set the threshold at a point of "N - 0.5 p.e.". Counting the number of pulses that exceed the threshold gives the number of times that N or more photons are simultaneously detected.

Dark count and crosstalk

The number of output pulses measured with no light incident on the MPPC under the condition that the threshold is set at "0.5 p.e." is usually viewed as a dark count (0.5 p.e. thr.). In some cases, the threshold set at "1.5 p.e" for measurement of the dark count (1.5 p.e. thr.) is used to evaluate crosstalk.



Measurement examples of dark count rate are indicated below.

[Figure 10] Dark count vs. reverse bias —— (a) S10362-11-025U/C







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[Figure 11] Dark count vs. ambient temperature — (a) \$10362-11-025U/C



(b) S10362-11-050U/C, S10362-11-100U/C



3-7 Photon detection efficiency (PDE), Dynamic range

Photon detection efficiency is a measure that indicates what percentage of the incident photons is detected. Not all carriers generated by the incident photons will create pulses large enough to be detected, so photon detection efficiency is expressed as the following equation. Photon detection efficiency increases as the bias voltage is increased.

PDE = Quantum efficiency \times Fill factor \times Avalanche probability \cdots (3)

Fill factor = Effective pixel size Total pixel size , Avalanche probability = Number of excited pixels Number of photon-incident pixels

The fill factor has a trade-off relation with the total number of pixels.

[Figure 12] Spectral response example



On the other hand, the total number of pixels determines the dynamic range for the simultaneously incident photons. Since each pixel only detects whether or not one or more photons have entered, the photon detection linearity lowers if the number of incident photons becomes large relative to the total number of pixels. This is because two or more photons begin to enter individual pixels.

Nfired = Ntotal ×
$$\left[1 - \exp\left(\frac{-Nphoton \times PDE}{Ntotal}\right)\right]$$
... (4)
Nfired : Number of excited pixels

Ntotal : Total number of pixels Nphoton: Number of incident photons





Their values (fill factor, total number of pixels, and dynamic range) determine possible applications suitable for the MPPC. (Refer to page 5.)



This section describes how to calculate the photon detection efficiency from the MPPC output current using a monochromator.

[Figure 14] Measurement setup for MPPC photon detection efficiency (using monochromator)



First, a photodiode with known spectral response characteristics is prepared. Based on its photo sensitivity at a given wavelength (ratio of photocurrent to incident light intensity, expressed in A/W units), the "number of photons incident on the photodiode" can be calculated from the photocurrent.

Next, the MPPC is installed in the same position as the photodiode and the MPPC spectral response is then measured. The gain obtained when a reverse bias voltage is applied should already be known by checking it beforehand. By dividing the photocurrent obtained from the spectral response measurement by the electric charge (1.6×10^{-19} C) of an electron, the "Number of photons detected by the MPPC" can be found.

The MPPC photon detection efficiency is then calculated as follows:



Note: Since the number of photons detected by the MPPC is calculated from the photocurrent, the photon detection efficiency obtained by the above equation also takes into account the effects from crosstalk and after-pulses.



Like all other photodetectors, the MPPC signal output contains time jitter.

(1) A time jitter is present from the time a photon enters the MPPC until the output pulse appears.



(2) When two photons enter the MPPC in a time period (between t1 and t2) shorter than the time jitter, then those two output pulses are embedded within the time jitter range, so the MPPC cannot measure the time difference between the two detected photons.



(3) When two photons enter the MPPC with a time period longer than the time jitter, the MPPC can measure the time difference between the two detected photons.



3-10 Time resolution measurement (by Transit Time Spread)

Time resolution is an important factor in applications requiring time accuracy.

The MPPC time resolution is obtained from the time jitter distribution. Figure 15 shows a time jitter distribution graph in which the horizontal axis represents the channel and the vertical axis the frequency. The time resolution is defined as the FWHM that is found by fitting this distribution using multiple Gaussian functions and a constant.

[Figure 15] Pulse response distribution



A connection diagram for MPPC time resolution measurement is shown below.

[Figure 16] Connection diagram for time resolution measurement



The pulse light source emits photons and simultaneously sends a start signal to the TAC. The TAC starts measuring the time upon receiving the start signal. Meanwhile, the photons enter the MPPC and the detected signals are amplified by the amplifier and sent to the CFD. The TAC receives each signal from the CFD as a stop signal and then provides a pulse output proportional to the time from when a photon entered the MPPC until the signal is measured. The MCA analyzes the pulses received from the TAC and sorts them into different channels according to pulse height. The data stored in the MCA displays a frequency distribution of MPPC responses (Figure 15).

Description of terms

[Afterpulse]

Afterpulses are spurious pulses following the true signal, which occur when the generated carriers are trapped by crystal defects and then released at a certain time delay. Afterpulses cause detection errors. The lower the temperature, the higher the probability that carriers may be trapped by crystal detects, so afterpulses will increase.

[Crosstalk]

In an avalanche multiplication process, photons might be generated which are different from photons initially incident on an APD pixel. If those generated photons are detected by other APD pixels, then the MPPC output shows a value higher than the number of photons that were actually input and detected by the MPPC. This phenomenon is called crosstalk in the MPPC.

[Dark count]

Output pulses are produced not only by photon-generated carriers but also by thermally-generated dark current carriers. The dark current pulses are measured as dark count which then causes detection errors. Although increasing the reverse bias voltage improves photon detection efficiency, it also increases the dark count. The dark count can be reduced by lowering the temperature.

[Excitation]

This is a phenomenon in which electron-hole pairs are generated in a photodiode by the energy of input photon when the photon energy is greater than the band gap.

[Fill factor]

The ratio of the active area size of a pixel to the total pixel size including circuits.

[Gain (Multiplication)]

The ratio of the number of multiplied electrons to one electron excited by one photon incident on the APD.

[Geiger discharge]

When an APD is operated at a reverse bias voltage higher than the breakdown voltage, a high electric field is produced, so that a discharge occurs even from a weak light input. This phenomenon is "Geiger discharge".

[Geiger mode]

Operation mode in which an APD is operated at a reverse bias voltage higher than the breakdown voltage. Geiger mode operation makes it possible to detect single photons.

[Multi-channel Analyzer: MCA]

This is a pulse height analyzer for analyzing and sorting the input analog pulses into different channels according to pulse height.

[p.e.]

This is an abbreviation for "photon equivalent".

Example: 1 p.e pulse = pulse with amplitude equivalent to one detected photon (including noise component)

[Time-to-Amplitude Converter: TAC]

Instrument for generating an output pulse height representing the time difference between two input signals.

[Time resolution]

The output pulse timing from an APD pixel may vary with the position of the APD pixel where a photon entered or with the photon input timing. Even if photons simultaneously enter different pixels at the same time, the output pulse from each pixel will not necessarily be the same time so that a fluctuation or time jitter occurs. When two photons enter APD pixels at a certain time difference which is shorter than this jitter, then that time difference is impossible to detect. Time resolution is the minimum time difference that can be detected by APD pixels and is defined as the FWHM of the distribution of the time jitter.

[Photon detection efficiency: PDE]

This is a measure of what percent of the incident photons were detected. Not all carriers generated by the incidence of photons will create pulses at an amplitude large enough to be detected, so photon detection efficiency is lower than quantum efficiency.

[Quantum efficiency: QE]

Quantum efficiency is a value showing the number of electrons or holes created as photocurrent divided by the number of incident photons, and is usually expressed as a percent. Quantum efficiency QE and photo sensitivity S (in A/W units) have the following relationship at a given wavelength λ (in nm units).

$$QE = \frac{S \times 1240}{\lambda} \times 100 \ [\%]$$

[Quenching]

This is the process of decreasing the voltage from VR to VBR to stop the Geiger discharge.

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1) "Development of Multi-Pixel Photon Counters"

S. Gomi, M. Taguchi, H. Hano, S. Itoh, T. Kubota, T. Maeda, Y. Mazuka, H. Otono, E.Sano, Y. Sudo,

T. Tsubokawa, M. Yamaoka, H. Yamazaki, S. Uozumi, T. Yoshioka, T. Iijima, K. Kawagoe, S. H. Kim,

T. Matsumura, K. Miyabayashi, T. Murakami, T. Nakadaira, T. Nakaya, T. Shinkawa, T. Takeshita, M. Yokoyama, and K. Yoshimura

2) "Development of Multi-Pixel Photon Counter (MPPC)"

K. Yamamoto, K. Yamamura, K. Sato, T. Ota, H. Suzuki, and S. Ohsuka

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